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IN THE CLAIMS:

Claims 1-25 (cancelled).

26. (currently amended) A projected beam detector comprising:

a beam source, and a beam sensor, the source and the sensor are configured to project a radiant energy beam on a path therebetween through at least part of a region being monitored;

a controllable optical obscuration member at least in part in the path, where the member has an obscuration state an a non-obscuration state;

a control circuit coupled to the source, the sensor, and the member and including circuits to switch the member from a non-obscuration state to an obscuration state to test beam alignment, whereby an electrical signal coupled from the sensor to the control circuit is indicative of results of a beam alignment test.

- 27. (previously presented) A detector as in claim 26 wherein the obscuration member is movable between the states by a transducer.
- 28. (previously presented) A detector as in claim 27 wherein the transducer comprises one of an electrically driven source of rotary motion and an electrically driven source of linear motion.
- 29. (previously presented) A detector as in claim 26 where the obscuration member comprises an element having an electrically alterable transmission characteristic wherein in response to a control electrical signal, the transmission characteristic switches from the optically transmissive condition to the less optically transmissive condition.
- 30. (previously presented) A method of testing a projected beam-type obscuration detector having a source for a beam of radiant energy and a sensor thereof, the method comprising:

projecting the beam from the source along an evaluating path through a region being monitored;

sensing the projected beam during a clear air condition subsequent to traversing the evaluating path;

automatically changing a transmissive characteristic of a part of the evaluating path thereby altering unscattered beam strength impinging on the sensor to conduct a beam alignment test.

- 31. (previously presented) A method as in claim 30 which includes maintaining a record of test results, and repeating the steps at least intermittently.
- 32 (previously presented) A method as in claim 30 where the transmissive characteristic is changed by optically blocking at least in part, the projected beam prior to the beam being sensed.
 - 33. (currently amended) A projected beam detector comprising:

a beam source, and a beam sensor, the source and the sensor are configured to project a radiant energy beam on a path therebetween through at least part of a region being monitored, the path having a length selected from a plurality of lengths;

a controllable obscuration member, wherein the member has a plurality of obscuration states and a non-obscuration state;

a control circuit coupled to the source, the sensor, and the member and including circuits to switch the member from a non-obscuration state to a selected obscuration state, selected based on path length, whereby an electrical signal coupled from the sensor to the control circuit is indicative of a test of sensed beam strength.

34. (previously presented) A detector as in claim 33 where the obscuration member is movable between the states by a transducer.

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35. (previously presented) A detector as in claim 33 where the obscuration member is electrically switchable between states thereby exhibiting an optically transmissive condition, relative to the beam, or a less optically transmissive condition, relative to the beam while at a common beam impinging location.

- 36. (previously presented) A detector as in claim 34 where the transducer comprises one of an electrically driven source of rotary motion and an electrically driven source of linear motion.
- 37. (previously presented) A detector as in claim 35 where the obscuration member comprises an element having an electrically alterable transmission characteristic wherein in response to a control electrical signal, the transmission characteristic switches from the optically transmissive condition to the less optically transmission condition.

38-41 (cancelled)

42. (currently amended) A test apparatus as in claim-40 for a projected beam-type detector comprising:

a control circuit which can be coupled to the detector;

an electrically controllable obscuration member which has at least first and second states, coupled to the control circuit, the first state corresponds to a normal operational state, the second state corresponding to partial optical obscuration, a test state, where the control circuit includes circuitry to test the detector by switching the obscuration member from the first, normal operational state to the second, test state to alter a beam transmission characteristic whereupon an output indicative of the test is coupled to control circuit; and

where the obscuration member includes a plurality of different test states with each test state associated with a predetermined beam path length between an emitter and a sensor, the control circuit including circuitry for selecting a test state responsive to a determined beam path length.

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43. (currently amended) A test apparatus as in claim 40 for a projected beam-type detector comprising:

a control circuit which can be coupled to the detector;

an electrically controllable obscuration member which has at least first and second states, coupled to the control circuit, the first state corresponds to a normal operational state, the second state corresponding to partial optical obscuration, a test state, where the control circuit includes circuitry to test the detector by switching the obscuration member from the first, normal operational state to the second, test state to alter a beam transmission characteristic whereupon an output indicative of the test is coupled to control circuit; and

where the obscuration member includes a beam alignment test state, the control circuit including circuitry to select that state to automatically test beam alignment.